

EXHIBIT D

Client - Confidential

The information used to prepare this report was based on interviews with The Scatter Works' engineers. The information was also based on inspections of the Advanced Particle Deposition System, Model APDS. This information was gathered over the period between April 3, 2000 and April 4, 2000. All observations and recommendations are based on conditions and descriptions of the Advanced Particle Deposition System, Model APDS, during the time of data collection and upon information made available to Global Semiconductor Safety Services (GS³). Manuals were evaluated as part of this assessment. This report's significance is subject to the adequacy and representative characteristics of the Advanced Particle Deposition System, Model APDS, and to the comprehensiveness of the tests, examinations, and/or surveys made. The Scatter Works represents that all information supplied by it or its agents to GS³ is accurate and complete and acknowledges that GS³ is relying upon such information in the preparation of this report without further verification by GS³ as to the accuracy or completeness of such information.

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